

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kazuhiro ATSUMI et al.

Application No.: 10/585,451

Confirmation No.: 2498

Filed: May 4, 2007

Art Unit: 3742

For: LASER PROCESSING METHOD AND
DEVICE

Examiner: J. S. Wasaff

AMENDMENT UNDER 37 C.F.R. § 1.114

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 20, 2011, the period for response to which extends through October 20, 2011, by operation of the concurrently filed three-month extension of time, please amend the above-identified U.S. patent application as follows in light of the filing of a Request for Continued Examination (RCE):

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper; and

Remarks/Arguments begin on page 21 of this paper.